

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fuminori HAYANO

Group Art Unit: 2877

Application No.: 10/760,586

Examiner:

I. AKANBI

Filed: January 21, 2004

Docket No.: 117681

For:

METHOD AND APPARATUS FOR MEASURING OPTICAL OVERLAY

DEVIATION

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the August 1, 2006 Office Action, please consider the following: Amendments to the Claims as reflected in the listing of claims; and

Remarks.